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## Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

## <u>Listing of Claims</u>:

. 1. (currently amended): A laser system that produces radiation at an operative wavelength, the system defining a laser cavity having an associated electric field pattern at the operative wavelength, and the system comprising:

a mode-locking element configured to mode-lock output of the laser system; and a semiconductor nonlinear increasing loss element that includes a semiconductor material having a band-gap larger than the energy of a photon at the operative wavelength and smaller than twice the energy of a photon at the operative wavelength, and

having a positioned within the cavity with respect to the electric field pattern and a thickness such that the semiconductor material to provides increasing absorption of radiation at the operative wavelength as energy density of radiation at a surface of within the semiconductor element material increases, to enhance stability of the mode-locked output.

- 2. (currently amended): The laser system of claim 1, wherein the semiconductor element comprises a semiconductor material that has a band edge greater than the operative wavelength, such that, at the operative wavelength, the material exhibits sufficient two-photon absorption[[,]] but not one photon absorption at the operative wavelength to achieve the increasing absorption.
- 3. (currently amended): The laser system of claim 2, further comprising a reflective structure disposed along an optical path in the cavity, wherein the semiconductor nonlinear

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increasing loss element comprises one or more layers of the semiconductor material disposed on the reflective structure.

4. (currently amended): The laser system of claim 1, wherein the semiconductor element eomprises a semiconductor material that has a conduction band, and the semiconductor material, when exposed to radiation having the operative wavelength, generates sufficient carriers in the conduction band to initiate sufficient free carrier absorption from the conduction band at the operative wavelength to produce achieve the increasing absorption.

- 5. (currently amended): The laser system of claim 4, further comprising a reflective structure disposed along an optical path in the cavity, wherein the semiconductor nonlinear increasing loss element comprises one or more layers of the semiconductor material disposed on the reflective structure.
- 6. (currently amended): The laser system of claim 1, further comprising a transmissive structure disposed along an optical path in the cavity, the transmissive structure including the semiconductor nonlinear increasing loss element.
- 7. (original): The laser system of claim 1, wherein the system is tunable to produce radiation over a wavelength range, the wavelength range including the operative wavelength.
- 8. (original): The laser system of claim 1, wherein the mode-locking element comprises a saturable absorber that passively mode-locks the laser system.
- 9. (original): The laser system of claim 1, wherein the mode-locking element comprises an external function generator driving a modulator that actively mode-locks the laser system.

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10. (currently amended): A laser system that defines a laser cavity having an associated electric field pattern at an operative wavelength, the system comprising:

a pump;

a gain medium that produces radiation at an the operative wavelength when pumped by the pump;

a reflector disposed along an optical path in the cavity, the reflector comprising one or more layers of a first semiconductor material that acts as a saturable absorber at the operative wavelength to mode-lock output of the laser system, and one or more layers of a second semiconductor material having a band-gap larger than the energy of a photon at the operative wavelength and smaller than twice the energy of a photon at the operative wavelength, and having a positioned within the cavity with respect to the electric field pattern and a thickness such that the second semiconductor material to provides increasing absorption of radiation at the operative wavelength as energy density of radiation at a surface of within the second semiconductor material increases, to enhance stability of the mode-locked output.

- 11. (currently amended): The laser system of claim 10, wherein the second semiconductor material produces exhibits sufficient two-photon absorption at the operative wavelength to achieve the increasing absorption.
- 12. (currently amended): The laser system of claim 44 10, wherein the reflector is configured such that, when light having the operative wavelength is incident upon the reflector, a resulting electric field within the reflector forms a standing wave within the reflector.
- 13. (original): The laser system of claim 12, wherein the standing wave has a local maximum at a location of one or more layers of the first semiconductor material.
- 14. (original): The laser system of claim 12, wherein the standing wave has a local maximum at a location of one or more layers of the second semiconductor material.

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15. (original): The laser system of claim 11, wherein the second semiconductor material comprises InP.

- 16. (original): The laser system of claim 15, wherein the first semiconductor material comprises InGaAs.
- 17. (original): The laser system of claim 15, wherein the gain medium comprises an Er/Yb waveguide.
- 18. (original): The laser system of claim 10, wherein the reflector further comprises a dielectric backmirror configured to reflect light having the operative wavelength.
- 19. (original): The laser system of claim 10, wherein the reflector further comprises a resonant coating or an anti-reflective coating.
- 20. (currently amended) A laser system that defines a laser cavity <u>having an associated</u> electric field pattern at an operative wavelength, the system comprising:

a pump;

a gain medium that produces radiation at an the operative wavelength when pumped by the pump;

an element that actively mode-locks output of the laser system;

a structure disposed along an optical path in the cavity, the structure comprising a semiconductor material having a band-gap larger than the energy of a photon at the operative wavelength and smaller than twice the energy of a photon at the operative wavelength, and having a positioned within the cavity with respect to the electric field pattern and a thickness such that the semiconductor material to provides increasing absorption of radiation at the

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operative wavelength as energy density of radiation at a surface of within the semiconductor material increases, to enhance stability of the mode-locked output.

21. (currently amended): The laser system of claim 20, wherein the semiconductor material produces exhibits sufficient two-photon absorption at the operative wavelength to achieve the increasing absorption.

- 22. (currently amended): The laser system of claim 24 20, wherein the structure comprises a reflector, the reflector comprising one or more layers of the semiconductor material.
- 23. (currently amended): The laser system of claim 24 20, wherein the structure comprises a transmissive substrate that includes the semiconductor material.
- 24. (original): The laser system of claim 23, wherein the structure comprises a waveguide.
- 25. (original): The laser system of claim 21, wherein the gain medium comprises erbium doped fiber, and the semiconductor material comprises InP.
- 26. (currently amended): A method of enhancing the stability of a continuous wave mode-locked output of a laser, the laser producing radiation at an operative wavelength and the laser defining a cavity having an associated electric field pattern at the operative wavelength and the laser producing radiation at an operative wavelength, the method comprising:

passively mode-locking the output of the laser to produce a continuous train of pulses; and

stabilizing the continuous train of pulses against intensity fluctuations by incorporating into the cavity a semiconductor nonlinear increasing loss element that includes a semiconductor material having a band-gap larger than the energy of a photon at the operative wavelength and

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smaller than twice the energy of a photon at the operative wavelength, and having a positioned within the eavity with respect to the electric field pattern and a thickness such that the semiconductor material to provides increasing absorption of radiation at the operative wavelength as energy density of radiation at a surface of within the semiconductor element material increases, to enhance stability of the mode-locked output.

- 27. (original): The method of claim 26, wherein the stabilizing step includes stabilizing the continuous train of pulses against Q-switched mode-locking.
- 28. (original): The method of claim 26, wherein the mode-locking step includes mode-locking by incorporating a saturable absorber into the cavity.
- 29. (currently amended): The method of claim 26, wherein the semiconductor element emprises a semiconductor material that exhibits sufficient two-photon absorption[[,]] but not one photon absorption, at the operative wavelength to achieve the increasing absorption.
- 30. (currently amended): The method of claim 29 26, wherein the stabilizing step includes incorporating a mirror into the cavity, the mirror having one or more layers that comprise the semiconductor material.
- 31. (currently amended): The method of claim 26, wherein the semiconductor element emprises a semiconductor material has a conduction band, and the semiconductor material, when exposed to radiation having the operative wavelength, generates sufficient carriers in the conduction band to initiate that exhibits sufficient free carrier absorption at the operative wavelength to achieve the increasing absorption.
- 32. (currently amended): A method of suppressing supermodes in the output of an actively mode-locked laser, the laser producing radiation at an operative wavelength and the

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laser defining a cavity having an associated electric field pattern at the operative wavelength and the laser producing radiation at an operative wavelength, the method comprising:

actively mode-locking the laser to produce a continuous train of pulses; and incorporating a semiconductor nonlinear increasing loss element into the cavity, the semiconductor nonlinear increasing loss element including a semiconductor material having a band-gap larger than the energy of a photon at the operative wavelength and smaller than twice the energy of a photon at the operative wavelength, and having a positioned within the cavity with respect to the electric field pattern and a thickness such that the semiconductor material to provides increasing absorption of radiation at the operative wavelength as energy density of radiation at a surface of within the semiconductor element material increases, to limit peak intensity of the pulses, and thereby suppress supermodes.

- 33. (currently amended): The method of claim 32, wherein the semiconductor element comprises a semiconductor material that exhibits sufficient two-photon absorption[[,]] but not one photon absorption, at the operative wavelength[[,]] to produce achieve the increasing absorption.
- 34. (currently amended): The method of claim 33 32, wherein the incorporating step includes incorporating a mirror into the cavity, the mirror including one or more layers of the semiconductor material.
- 35. (currently amended): The method of claim 33 32, wherein the incorporating step includes incorporating a waveguide into the cavity, the waveguide being partly formed from the semiconductor material.